

PETITION MOOT

APPLICATION ALLOWED.



HIEN H. PHAN
SPECIAL PROGRAM EXAMINER
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In The United States Patent And Trademark Office

I hereby certify that this is being deposited with the United States Postal Service as first class mail to Addressee service under 37 CFR 1.10 addressed to the Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313 on 2-7-04

By


Mario Rabinowitz

February 3, 2003

In re Pro Se application of Mario Rabinowitz

Serial No. : 10/760,068

Filed: 1-16-04.

Title: Advanced Micro-Optics Solar Energy Collection System

Examiner: Unknown as of this date.

Art. Unit: Unknown as of this date, but probably 2872.

No fee required as this invention will contribute to Energy Conservation.

PETITION TO MAKE SPECIAL

Pursuant to U.S. Patent Law, Manual of Patent Examining Procedure § 708.02, 37 CFR 1.102. *Advancement of examination*, the applicant, U.S. citizen:

Mario Rabinowitz

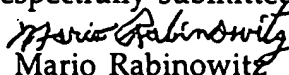
hereby petitions the U.S. Commissioner of Patents to make special his patent application for a

Advanced Micro-Optics Solar Energy Collection System

The basis of this petition is that my invention will materially contribute to and promote the development of energy conservation resources. In the process of advancing the conservation of energy, my invention may also be expected to enhance the quality of the environment. My invention will make solar energy practical in allowing the solar energy conversion system to be low in capital cost and inexpensive to install. In its capacity as a power producer, it can be utilized with far greater safety, simplicity, economy, and efficiency in the conversion of solar energy. It will thus also benefit the environment in obviating the necessity to use other polluting energy sources.

I pray that the The United States Patent And Trademark Office will accord "special" status to my patent application for the reasons given above.

Respectfully submitted,


Mario Rabinowitz

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